03500.013000.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

'In re A	application of:)	
YOSHIHIRO ISHIDA ET AL.			Examiner: Lin Ye
Applic	cation No.: 09/164,624	:)	Group Art Unit: 2612
Filed:	October 1, 1998	;	Confirmation No.: 6892
For:	MONITORING SYSTEM APPARATUS AND PROCESSING METHOD	; ; ;	July 2 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed, together with a copy of a Japanese Official Action citing them, and a translation of that Action.

For the concise explanation of relevance for the non-English documents, the Examiner is referred to the accompanying English abstracts.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

July 2, 2004 (Date of Deposit)

(Name of Attorney for Applicant)

July July

BEST AVAILABLE COPY

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Leonard P. Diana

Registration No.: 29,296

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza

New York, New York 10112-3800 Facsimile: (212) 218-2200

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FORM PTO 1449 (modified)				ATT	ATTY DOCKET NO. APPLICATION NO.						
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				035	03500.013000. 09/164,624						
LIST OF REFERENCES CITED BY APPLICANT (\$) (Use several sheets if necessary)				APPI	APPLICANT						
/ YOSHIHIRO ISHIDA ET AL.											
(JUL 0 7 2004 👸)				FILIN	IG DATE	GROUP					
					tober 1, 1998		2612				
U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE		NAME	CLAS	SUBCLASS	FILING DATE IF APPROPRIATE			
						R	ECEN	/ED			
							JUL 1 2 2	004			
						Tech	nology Cen	ter 2600			
FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER	DATE		COUNTRY	CLAS	S SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT			
	JP	07-220095	8/18/1995		Japan			Yes			
	JP	04-077067	3/11/1992		Japan			Yes			
	JP	05-183901	7/23/1993		Japan			Yes			
	_										
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)											
EXAMINER		1			DATE CONSIDERED						

Sheet 1 of 1

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.